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Substitute for form 1449/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)		Complete if Known			
		Application Number	10/688,186 – Conf. #4125		
		Filing Date	September 24, 2003		
		First Named Inventor	Yutaka TAKAFUJI		
		Art Unit	2813		
		Examiner Name	MENZ, Laura Mary		
Sheet	1	of	1	Attorney Docket Number	1248-0673P

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind ² Code ² (if known)			
	AA*	US-2002/0047169*	04-25-2002	Kunikiyo	

FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages Or Relevant Figures Appear	T ²
		Country Code ³ -Number ⁴ -Kind Code ⁵ (if known)				
	BA	JP-06-289421	10-18-1994	Matsushita Electric Ind. Co. Ltd.		✓
	BB	JP-2002-076336	03-15-2002	Mitsubishi Electric Corp.		ABS

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
	CA	C. GUI et al., "The effect of surface roughness on direct wafer bonding," Journal of Applied Physics, May 15, 1999, Volume 85, No. 10, pp. 7448-7454	

Examiner Signature	Date Considered
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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*) corresponding to JP 2002-76336A (BB)

Date: November 26, 2008

Not considered

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